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Attorney's Docket No.: 05542-450001 / 4563-3/CMP

\$2817

#6 / 7-20-02
H.R.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Fritz Redeker et al.

Art Unit : 2812

Serial No. : 09/918,591

Examiner : Angel Roman

Filed : July 27, 2001

Title : CHEMICAL MECHANICAL POLISHING OF A METAL LAYER WITH
POLISHING RATE MONITORING

Commissioner for Patents
Washington, D.C. 20231

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INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of §1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 6/14/02

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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07/02/2002 JADD01 00000058 09918591

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